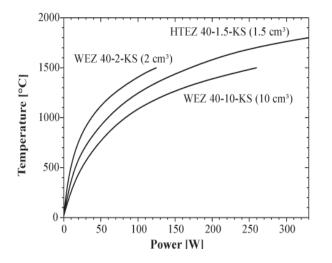
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## COMPACT EFFUSION CELLS WEZ / NTEZ / HTEZ

- Compact and robust cell design
- Cooling shroud and shutter integrated
- Clean operation in UHV systems
- Excellent temperature and flux stability
- Low power consumption
- Optimised low temperature cells



Material	M. P. *	Т ор.**	Source Type	Filament
Zn	419 °C	250 °C	NTEZ	HL
Mg	649 °C	327 °C	NTEZ	SF
Са	842 °C	459 °C	NTEZ	HL
In	157 °C	742 °C	WEZ	HL
Ag	961 °C	832 °C	WEZ	SF
Ga	30 °C	907 °C	WEZ	HL
AI	660 °C	972 °C	WEZ	CL
Cu	1084 °C	1027 °C	WEZ / HTEZ	HL
Au	1063 °C	1132 °C	WEZ / HTEZ	SF
Ge	937 °C	1167 °C	WEZ / HTEZ	SF
Fe	1535 °C	1180 °C	WEZ / HTEZ	SF

\* Melting point



Compact effusion cell on DN40 CF (0.D. 2.75") flange with a 10 cm<sup>3</sup> PBN crucible, integrated cooling shroud and shutter

Effusion cells of the Knudsen type are generally used to evaporate or sublimate a great variety of materials. The evaporant in the crucible is heated by tantalum or tungsten wire filaments while the heater is shielded by multiple layers of tantalum foil. Only high quality refractory metals such as W and Ta are used in the hot area to obtain high purity and low outgassing at high temperatures.

Excellent operation temperature stability of  $\pm 0.1$  K and therefore very stable flux rates are achieved by PID control of the operating temperature. Standard crucible material is PBN (pyrolytic boron nitride), which is a very clean and stable ceramic material. Other crucible materials such as  $Al_2O_3$ , BeO, tungsten, pyrolytic graphite (PG) or quartz are available as requested.

The compact cell design with integrated water cooling and shutter on a DN40CF (O.D. 2.75") mounting flange is ideally suited for small research surface analysis systems and ensures effective water cooling around the cell, protecting both vacuum chamber and port tubes and thus minimizing the heat load by thermal radiation.

For evaporation of high vapor pressure materials and organic molecules the low temperature effusion cell NTEZ is recommended. Standard effusion cells WEZ are suitable for most materials evaporated at temperatures from 700 to 1400°C. For applications at higher temperatures the high temperature effusion cell HTEZ with a free-standing tungsten filament can be used.

WEZ and NTEZ cells are provided with standard, hot lip, cold lip or dual filament, to cover different evaporation material requirements.

<sup>\*\*</sup> Typical operating temperatures required for growth rates in the range of 0.1 to 0.5 ML/s (about 1-3 nm/min) using a WEZ 40-10-22-KS at a source to sample distance of 100mm

## Applications

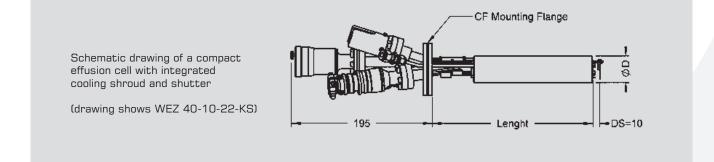
Compact effusion cells in combination with DC power supplies and PID temperature controllers are an economically priced solution for thin film deposition in surface analysis systems or small sample preparation chambers.

The concept of a radiation-heated crucible enables evaporation of most materials and is especially suited for materials that melt before a sufficient evaporation rate is reached. We provide compact effusion cells for high vapor pressure materials and for low vapor pressure materials. Typical operating temperatures for various materials are listed in the table overleaf. Due to the compact design minimum power is needed for our high temperature cells.

The simple and robust cell design allows changing of the evaporation material by a simple crucible exchange procedure. Large crucible capacities guarantee long operation periods without refilling or service. Precise temperature measurement and control produces very stable and reproducible growth rates in an extremely wide range from below 0.01 nm/h (e.g. doping applications) up to several nm/s for thin film growth. A temperature variation of typically 100°C changes the flux about one order of magnitude. By using thermal evaporation, ionisation processes, which could lead to ion-induced damages of the sample, are avoided.

## Technical Data

Mounting flange	DN40CF (0.D. 2.75")		
Dimensions in vacuum	190-400 mm / Ø34 mm for NTEZ / WEZ 40-2-16-KS;		
	220-400 mm / Ø36 mm for NTEZ / WEZ 40-10-22-KS; HTEZ 40-1-19-KS		
Filament type	Ta wire filament: standard (SF), hot lip (HL), cold lip (CL), dual (DF) for		
	NTEZ / WEZ; free standing tungsten heater for HTEZ		
Thermocouple	W5%Re/W26%Re (type C) or NiCr/NiAI (type K)		
Bakeout temperature	max. 250°C		
Operating temperature	80-1000°C (NTEZ); 700-1400°C (WEZ); 800-1700°C (HTEZ)		
Outgassing temperature	max. 800°C/1100°C (NTEZ); max. 1500°C (WEZ); max. 1900°C (HTEZ)		
Cooling	integrated water cooling shroud ( <b>K</b> )		
Shutter	integrated rotary shutter ( <b>S</b> ) with Ta shutter plate		
Crucibles	1.5 cm <sup>3</sup> (PBN, Al <sub>2</sub> O <sub>3</sub> , BeO, PG, W) for HTEZ		
	2 cm³ (PBN) for WEZ / NTEZ		
	10 cm³ (PBN, Al <sub>2</sub> O <sub>3</sub> , PG, quartz) for WEZ / NTEZ		



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